



1 Inventor: Dan G. Custer et al.

2 Title: Polishing Systems, Method of Polishing Substrates, and Methods
3 of Preparing Liquids for Semiconductor Fabrication Processes

4 Assignee: Micron Technology, Inc.

5 Serial No.: 09/298,160

6 Filing Date: April 22, 1999

7 **SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

8 **PURSUANT TO 37 C.F.R. §§1.56, 1.97 AND 1.98**

9 In compliance with 37 C.F.R. §§1.56, 1.97 and 1.98, your attention is
10 directed to the United States patent listed on the attached Form PTO-1449,
11 and copies of which are attached.

12 Citation of these references is respectfully requested.

13 Respectfully submitted,

14 Dated: 10/13/99

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Application Number	09/298,160
Filing Date	April 22, 1999
First Named Inventor	Dan G. Custer
Group Art Unit	1763
Examiner Name	Unknown

Attorney Docket Number MI22-1172

ENCLOSURES (check all that apply)

<input type="checkbox"/> Fee Transmittal Form	<input type="checkbox"/> Assignment Papers (for an Application)	<input type="checkbox"/> After Allowance Communication to Group
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<input type="checkbox"/> Affidavits/declaration(s)	<input type="checkbox"/> Petition to Convert to a Provisional Application	<input type="checkbox"/> Status Letter
<input type="checkbox"/> Extension of Time Request	<input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address	<input checked="" type="checkbox"/> Additional Enclosure(s) (please identify below):
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Firm or Individual name	David G. Latwesen, Ph.D.
Signature	
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